

Notice of References Cited

Application/Control No.

10/533,677

Applicant(s)/Patent Under
Reexamination
DE LUCA ET AL.

Examiner

JEONG S. PARK

Art Unit

2154

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0143961	10-2002	Siegel et al.	709/229
*	B	US-6,434,700	08-2002	Alonso et al.	713/169
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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